

**CLAIM AMENDMENTS**

Please cancel previously withdrawn Claims 25-42 as follows:

1. (Previously Presented) A high pressure system, comprising a high pressure apparatus including:
  - a) a plurality of pressure members configured to form a high pressure volume; and
  - b) a first high pressure reaction assembly which is placed in the high pressure volume, said reaction assembly comprising:
    - i) a first catalyst layer having a crystal growth surface and a raw material flux surface;
    - ii) at least one crystalline seed contacting the catalyst layer; and
    - iii) a raw material layer adjacent the raw material flux surface of the first catalyst layer, the raw material layer being configured to allow raw material to diffuse into the catalyst layer along a bulk raw material diffusion direction that is oriented substantially perpendicular to gravity within the high pressure volume during application of high pressure.
2. (Original) The system of claim 1, further comprising a second catalyst layer having a crystal growth surface and a raw material flux surface and at least one crystalline seed contacting the second catalyst layer, said raw material flux surface of the second catalyst layer being adjacent the raw material layer opposite the first catalyst layer.
3. (Original) The system of claim 1 or 2, further comprising a support layer in contact with the crystal growth surface of the catalyst layer.
4. (Original) The system of claim 3, wherein the crystalline seed contacts the crystal growth surface and the support layer at least partially surrounds each crystalline seed.
5. (Original) The system of claim 4, further comprising a second reaction assembly adjacent the first wherein the first and second reaction assemblies share a common support layer.

6. (Original) The system of claim 3, further comprising a plurality of reaction assemblies oriented in series within the high pressure volume.
7. (Original) The system of claim 1, further comprising a plurality of high pressure apparatuses oriented in parallel.
8. (Original) The system of claim 1, further comprising a plurality of high pressure apparatuses oriented in series.
9. (Previously Presented) The system of claim 1, wherein the raw material is a carbon source configured for growing diamond from the crystalline seed.
10. (Original) The system of claim 9, wherein said catalyst layer comprises a carbon solvent selected from the group consisting of Fe, Ni, Co, Mn, Cr, and alloys thereof.
11. (Original) The system of claim 10, wherein said catalyst layer comprises an Fe-Ni alloy.
12. (Original) The system of claim 9, wherein said raw material layer comprises low resistivity graphite.
13. (Original) The system of claim 9, wherein said raw material layer comprises diamond powder.
14. (Original) The system of claim 1, wherein the raw material is a low pressure phase boron nitride source configured for growing cubic boron nitride from the crystalline seed.
15. (Original) The system of claim 14, wherein the catalyst material is a member selected from the group consisting of alkali, alkaline earth metal, and compounds thereof.

16. (Original) The system of claim 1, wherein the crystalline seed is a member selected from the group consisting of diamond seed, cBN seed, SiC seed, and combinations thereof.

17. (Original) The system of claim 1, wherein said plurality of pressure members comprises a high pressure press selected from the group consisting of split die device, piston-cylinder press, girdle device, belt device, tetrahedral press, cubic press, and toroidal device.

18. (Original) The system of claim 17, wherein said pressure members are a split die device, comprising:

- a) a plurality of complementary die segments, each die segment having an inner surface and an outer surface, wherein the inner surfaces are configured to form a die chamber having a chamber axis upon assembly of the plurality of die segments, said chamber axis being oriented substantially perpendicular to gravity during application of high pressure;
- b) a pair of anvils oriented such that an anvil is at each end of the die chamber and configured to apply force substantially along the chamber axis; and
- c) a plurality of force members operatively connected to the plurality of die segments and configured to apply a plurality of discrete forces to the plurality of die segments sufficient to retain the plurality of die segments in substantially fixed positions relative to each other during application of force by the pair of anvils.

19. (Original) The system of claim 18, comprising from two to ten complementary die segments.

20. (Original) The system of claim 18, wherein the die chamber has a length of from about 0.5 to about 10 times the minimum diameter.

21. (Original) The system of claim 18, wherein the discrete forces intersect at a common point and act in a common plane substantially perpendicular to the chamber axis.

22. (Original) The system of claim 18, wherein the die chamber has a reaction volume from about 5 cm<sup>3</sup> to about 500 cm<sup>3</sup>.

23. (Original) The system of claim 18, further comprising a plurality of split die devices oriented in series, wherein said devices share at least one common anvil, said anvil having two ends, each configured to apply force substantially along the chamber axis.

24. (Original) The system of claim 18, further comprising a plurality of split die devices oriented in parallel, wherein said devices share common force members.

25-42. (Canceled)